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Vertical-Cavity Surface-Emitting Lasers XIII

**Kent D. Choquette
Chun Lei**
Editors

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Contents

vii *Conference Committee*

SESSION 1 **ADVANCING VCSEL PERFORMANCE**

- 7229 02 **Highly reliable high speed 1.1 μ m-InGaAs/GaAsP-VCSELS (Invited Paper)** [7229-01]
H. Hatakeyama, T. Anan, T. Akagawa, K. Fukatsu, N. Suzuki, K. Tokutome, M. Tsuji, NEC Corp. (Japan)
- 7229 03 **Progress in high-power high-efficiency VCSEL arrays (Invited Paper)** [7229-02]
J.-F. Seurin, G. Xu, V. Khalfin, A. Miglo, J. D. Wynn, P. Pradhan, C. L. Ghosh, L. A. D'Asaro, Princeton Optronics (United States)
- 7229 04 **High volume 850nm oxide VCSEL development for high bandwidth optical data link applications (Invited Paper)** [7229-03]
C. Ji, J. Wang, D. Söderstrom, K.-L. Chen, R. Murty, M. Keever, L. Giovane, Avago Technologies (United States); J.-K. Hwang, G.-H. Koh, J. Tan, J. Chu, Avago Technologies (Singapore)
- 7229 05 **More VCSELS at Finisar (Invited Paper)** [7229-04]
J. Guenter, B. Hawkins, R. Hawthorne, R. Johnson, G. Landry, K. Wade, Finisar (United States)

SESSION 2 **EMERGING VCSEL APPLICATIONS**

- 7229 06 **Optical sub-assembly solution for single fiber optical HDMI connector (Invited Paper)** [7229-05]
S.-C. Liu, R. R. Liu, W.-P. Chen, C. Z. Wu, J.-S. Pan, TrueLight Corp. (Taiwan)
- 7229 07 **Narrow linewidth VCSELS for high-resolution spectroscopy (Invited Paper)** [7229-06]
D. K. Serkland, G. A. Keeler, K. M. Geib, G. M. Peake, Sandia National Labs. (United States)
- 7229 08 **VCSEL-based optical trapping for microparticle manipulation (Invited Paper)** [7229-07]
R. Michalzik, A. Kroner, A. Bergmann, F. Rinaldi, Ulm Univ. (Germany)
- 7229 09 **Vertical-cavity surface-emitting lasers for optical sensing in microfluidic microsystems** [7229-08]
A. M. Kasten, J. D. Tice, A. V. Giannopoulos, V. B. Verma, P. J. A. Kenis, K. D. Choquette, Univ. of Illinois (United States)

SESSION 3 **VCSEL WAVELENGTHS**

- 7229 0B **New developments in 850 and 1300nm VCSELS at JDSU (Invited Paper)** [7229-10]
L. A. Graham, M. Schnoes, K. D. Maranowski, T. R. Fanning, M. V. Crom, S. A. Feld, M. H. Gray, K. Bowers, S. L. Silva, K. Cook, G. Schomberger, B. Gable, JDSU (United States)

- 7229 0C **120°C 20 Gbit/s operation of 980nm VCSEL based on sub-monolayer growth (Invited Paper)** [7229-11]
F. Hopfer, A. Mutig, G. Fiol, P. Moser, D. Arsenijevic, Technische Univ. Berlin (Germany); V. A. Shchukin, N. N. Ledentsov, VI Systems GmbH (Germany); S. S. S. Mikhrin, I. L. Krestnikov, D. A. Livshits, A. R. Kovsh, Innolume GmbH (Germany); M. Kuntz, Technische Univ. Berlin (Germany) and Univ. of California, Berkeley (United States); D. Bimberg, Technische Univ. Berlin (Germany)
- 7229 0D **An efficient electro-thermo-optical model for vectorial and 3D VCSEL simulation (Invited Paper)** [7229-12]
P. Debernardi, IEIT-CNR, Politecnico di Torino (Italy)

SESSION 4 NOVEL VCSEL STRUCTURES

- 7229 0E **Integrated photodiodes complement the VCSEL platform** [7229-13]
M. Grabherr, P. Gerlach, R. King, R. Jäger, Philips Technologie GmbH ULM Photonics (Germany)
- 7229 0G **Tapered hollow waveguide multiplexer for multi-wavelength VCSEL array** [7229-15]
A. Imamura, K. Hasebe, A. Matsutani, F. Koyama, Tokyo Institute of Technology (Japan)
- 7229 0H **Beam forming of light from structured metal nano-aperture vertical cavity lasers** [7229-16]
J. D. Sulkin, C. Chen, P. M. Ferreira, K. D. Choquette, Univ. of Illinois (United States)
- 7229 0I **Optical coupling for Bragg reflector slow light waveguide using micro-corner mirror** [7229-17]
T. Fujisawa, A. Fuchida, F. Koyama, Tokyo Institute of Technology (Japan)

SESSION 5 MODULATION AND SHORT PULSE

- 7229 0K **VCSEL with intracavity modulator: fast modulation options** [7229-19]
M. Yakimov, V. Tokranov, A. Sergeev, S. Oktyabrsky, Univ. at Albany, SUNY (United States)

POSTER SESSION

- 7229 0N **Design rules of high reflectivity Bragg GaAIN mirrors for 300nm VCSELs** [7229-22]
C. Alhenc-Gelas, P. Heroin, Supelec, Lab. Matériaux Optique Photonique et Systèmes, CNRS (France); M. Abid, Georgia Institute of Technology, CNRS (France); J. Jacquet, Supelec, Lab. Matériaux Optique Photonique et Systèmes, CNRS (France); S. Gautier, Lab. Matériaux Optique Photonique et Systèmes, CNRS, Univ. Paul Verlaine de Metz (France); A. Ougazzaden, Georgia Institute of Technology, CNRS (France)
- 7229 0O **2.49 GHz low phase-noise optoelectronic oscillator using 1.55µm VCSEL for avionics and aerospace applications** [7229-23]
A. Hayat, A. Bacou, A. Rissons, J.-C. Mollier, DEOS/MOSE ISAE (France)

7229 OP

Signal structure and sensitive detection of molecular species: optimal experimental techniques in modulation broadened wavelength modulation spectroscopy (Invited Paper)
[7229-24]

M. A. Khan, K. D. Mohan, A. N. Dharamsi, Old Dominion Univ. (United States)

Author Index

Conference Committee

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1 Advancing VCSEL Performance
Chun Lei, Emcore Corporation (United States)

2 Emerging VCSEL Applications
Kent D. Choquette, University of Illinois at Urbana-Champaign (United States)

- 3 VCSEL Wavelengths
Krassimir Panajotov, Vrije Universiteit Brussel (Belgium)
- 4 Novel VCSEL Structures
Kent M. Geib, Sandia National Laboratories (United States)
- 5 Modulation and Short Pulse
James K. Guenter, Finisar Corporation (United States)